

INFORMATION DISCLOSURE CITATION:

(Use several sheets if necessary)

Page 1 of 3

007272-000053.305503

Atty. Docket No.: 7272-53

Serial No.: 10/822,619

Applicant Han Nee

Filing Date: April 12, 2004

Group Art: 1774

U.S. PATENT DOCUMENTS

Examiner Initial		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	Filing Date If appropriate
S. Nee		6,790,503	09/14/04	Nee			
	*	6,232,036	05/15/01	Suzuki et al.			
	*	US 2003/0180495 A1	09/25/03	Ito et al.			
	*	US 2003/0215598 A1	11/20/03	Nee			
	*	4,404,656	9/13/83	Cornet et al.			
	*	4,405,994	9/20/83	Cornet et al.			
	*	4,450,553	5/22/84	Holster et al.			
	*	4,709,363	11/24/87	Dirks et al.			
	*	4,998,239	3/5/91	Strandjord et al.			
	*	5,090,009	2/18/92	Hamada et al.			
	*	5,093,174	3/3/92	Suzuki et al.			
	*	5,171,392	12/15/92	Iida et al.			
	*	5,325,351	6/28/94	Uchiyama et al.			
	*	5,391,462	2/21/95	Arioka et al.			
	*	5,415,914	5/16/95	Arioka et al.			
	*	5,419,939	5/30/95	Arioka et al.			
	*	5,498,507	3/12/96	Handa et al.			
	*	5,620,767	4/15/97	Harigaya et al.			
	*	5,640,382	6/17/97	Florczak et al.			
	*	5,820,994	10/13/98	Gotoh et al.			
	*	6,007,889	12/28/99	Nee			
	*	6,280,811	08/28/01	Nee			
	*	6,451,402	09/17/02	Nee			
	*	5,853,872	12/29/98	Shimamori et al.			
	*	5,753,413	05/19/98	Nishida et al.			
	*	5,948,497	09/07/99	Hatwar et al.			
	*	5,093,174	03/03/92	Suzuki et al.			
	*	6,544,616	04/08/03	Nee			
	*	6,007,887	12/28/99	Hatwar et al.			
	*	6,228,457	05/08/01	Ueno et al.			
	*	US2003/0081537	05/01/03	Shinotsuka			
	*	US2002/0150772	10/17/02	Nakai et al.			
	*	US2003/0003395	01/02/03	Yuzurihara et al.			
	*	US2003/0008236	01/09/03	Yamada et al.			
	*	US2002/0122913	09/05/02	Nee			
*	US2002/0034603	03/21/02	Nee				
*	5,673,251	09/30/97	Suzuki et al.				
*	6,242,068 B1	06/05/01	Preuss				
*	6,292,457 B1	09/18/01	Preuss et al.				
*	6,351,446 B1	02/26/02	Weinzerl et al.				

Examiner

Date Considered

Examiner: initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



INFORMATION DISCLOSURE CITATION:

(Use several sheets if necessary)

Page 2 of 3

Atty. Docket No.: 7272-53

Serial No.: 10/822,619

Applicant: Han Nee

Filing Date: April 12, 2004

Group Art: 1774

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							Yes	No
	*	03286432A	12/17/91	JP				
	*	05012710	1/22/93	JP				
	*	07014221A	1/17/95	JP				
	*	07105575A	4/21/95	JP				
	*	08297858	11/12/96	JP				
	*	09007226	1/10/97	JP				
	*	08158147	1/19/98	JP				
	*	08149725	12/2/97	JP				
	*	08115029	11/28/97	JP				
	*	08050199	9/19/97	JP				
	*	08019648	8/15/97	JP				
	*	08014667	8/5/97	JP				
	*	08035523	8/5/97	JP				
	*	07139459	12/17/96	JP				
	*	07076177	10/18/96	JP				
	*	07038628	9/13/96	JP				
	*	07223758	5/17/96	JP				
	*	06253971	5/17/96	JP				
	*	06206963	3/22/96	JP				
	*	06225691	3/8/96	JP				
	*	06141602	1/12/96	JP				
	*	06143042	1/12/96	JP				
	*	06123718	12/22/95	JP				
	*	06111259	12/8/95	JP				
	*	07116045	12/8/95	JP				
	*	07036958	10/13/95	JP				
	*	06065594	10/3/95	JP				
	*	05312129	6/27/95	JP				
	*	05277809	4/25/95	JP				
	*	05251824	4/21/95	JP				
	*	05249821	4/4/95	JP				
	*	05233110	3/31/95	JP				
	*	05179739	3/20/95	JP				
	*	05215547	3/17/95	JP				
	*	05195011	2/21/95	JP				
	*	06107566	1/6/95	JP				
	*	05115763	11/25/94	JP				
	*	05215634	9/30/94	JP				

Examiner

Date Considered

1-13-05

Examiner: initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION:

(Use several sheets if necessary)

Page 3 of 3

Atty. Docket No.: 7272-53

Serial No.: 10/822,619

Applicant: Han Nee

Filing Date: April 12, 2004

Group Art: 1774

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							Yes	No
	*	04-176039	06/23/92	JP				
	*	WO 00/21079	4/13/00	PCT				
	*	WO 97/22968	06/26/97	PCT				
	*	273193/96	10/18/96	JP				
	*	324133/92	11/13/92	JP				
	*	325406/94	05/10/93	JP				
	*	25515/99	07/03/97	JP				
	*	WO 02/2054396	07/11/02	PCT				
	*	2,401,389	07/11/02	CA				
	*	2000-402146	07/11/02	JP				
	*	2000-228032	08/15/00	JP				
	*	10-177742	06/30/98	JP				
	*	403025737	02/04/91	JP				
	*	411012734	01/19/99	JP				
	*	0 798 401 A2	10/01/97	EP				
	*	0 720 159 A2	07/03/96	EP				
	*	0 745 985 A2	12/04/96	EP				
	*	0 737 966 A1	10/16/96	EP				
	*	07-006427	01/10/95	JP				
	*	XP-002260270	06/12/92	JP				
	*	0 917 137 A1	05/19/99	EP				
	*	0 867 868 A2	09/30/98	EP				

NON PATENT DOCUMENTS

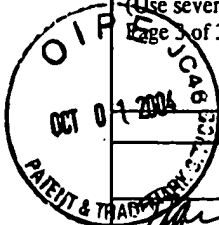
*Examiner Initial	PUBLICATION
↓	* English Translation of PCT Publication No. WO 00/21079.
	* English Translation of EP Publication No. 0 594 516 B1
	* English Translation of JP Publication No. 02-192046
	* English Translation of JP Publication No. 10-011799
	* English Translation of JP Publication No. 09-212915
	* English Translation of JP Publication No. 07-105575
↓	* BOND, W.L. Notes on Solution of Problems in Odd Job Vapor Coating, J. Optical Society of America, June 1954, pp. 429-38, Vol. 44, No. 6.

Examiner

22 Alchvancy

Date Considered

1-13-05



INFORMATION DISCLOSURE CITATION		Atty. Docket No.: 7272-53		Application No.: 10/822,619		
Page 1 of 4 Pages						
7272-53/312402		Applicant: Han H. Nee				
		Filing Date: April 12, 2004		Group Art Unit: 1774		
U.S. PATENT DOCUMENTS						
Examiner Initial	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	Filing Date If appropriate
JHE	6,764,735	07/20/04	Nee			
	5,719,006	2/17/98	Ohkubo			
	5,741,603	4/21/98	Yasuda			
	US2004/0048193 A1	03/11/04	Lichtenger et al.			
	US2004/0005432 A1	01/08/04	Ridout et al.			
	US2004/0161630 A1	08/19/04	Specht et al.			
	* 4,404,656	9/13/83	Cornet et al.			
	* 4,405,994	9/20/83	Cornet et al.			
	* 4,450,553	5/22/84	Holster et al.			
	* 4,709,363	11/24/87	Dirks et al.			
	* 4,998,239	3/5/91	Strandjord et al.			
	* 5,090,009	2/18/92	Hamada et al.			
	* 5,093,174	3/3/92	Suzuki et al.			
	* 5,171,392	12/15/92	Iida et al.			
	* 5,325,351	6/28/94	Uchiyama et al.			
	* 5,391,462	2/21/95	Arioka et al.			
	* 5,415,914	5/16/95	Arioka et al.			
	* 5,419,939	5/30/95	Arioka et al.			
	* 5,498,507	3/12/96	Handa et al.			
	* 5,620,767	4/15/97	Harigaya et al.			
	* 5,640,382	6/17/97	Florczak et al.			
	* 5,673,251	09/30/97	Suzuki et al.			
	* 5,753,413	05/19/98	Nishida et al.			
	* 5,820,994	10/13/98	Gotoh et al.			
	* 5,853,872	12/29/98	Shimamori et al.			
	* 5,948,497	09/07/99	Hatwar et al.			
	* 6,007,887	12/28/99	Hatwar et al.			
	* 6,007,889	12/28/99	Nee			
	* 6,228,457	05/08/01	Ueno et al.			
	* 6,232,036	05/15/01	Suzuki et al.			
	* 6,242,068 B1	06/05/01	Preuss			
* 6,280,811	08/28/01	Nee				
* 6,292,457 B1	09/18/01	Preuss et al.				
* 6,351,446 B1	02/26/02	Weinzerl et al.				
* 6,451,402	09/17/02	Nee				
* 6,544,616	04/08/03	Nee				
* 6,790,503	09/14/04	Nee				
* US2002/0034603	03/21/02	Nee				
Examiner	Date Considered					
JHE	1-13-05					

Examiner: initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.


Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number

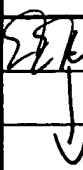

INFORMATION DISCLOSURE CITATION		Atty. Docket No.: 7272-53		Application No.: 10/822,619			
Page 2 of 4 Pages 7272-53/312402		Applicant: Han H. Nee					
		Filing Date: April 12, 2004		Group Art Unit: 1774			
U.S. PATENT DOCUMENTS							
Examiner Initial		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	Filing Date If appropriate
SM	*	US2002/0150772	10/17/02	Nakai et al.			
	*	US2002/0122913	09/05/02	Nee			
	*	US2003/0003395	01/02/03	Yuzurihara et al.			
	*	US2003/0008236	01/09/03	Yamada et al.			
	*	US2003/0081537	05/01/03	Shinotsuka			
	*	US2003/0180495 A1	09/25/03	Ito et al.			
	*	US2003/0215598 A1	11/20/03	Nee			
Examiner	22 H. W. Nee			Date Considered			
1-13-05							
Examiner: initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number

INFORMATION DISCLOSURE CITATION				Atty. Docket No.: 7272-53		Application No.: 10/822,619		
Page 3 of 4 Pages 7272-53/312402				Applicant : Han H. Nee				
				Filing Date: April 12, 2004		Group Art Unit: 1774		
FOREIGN PATENT DOCUMENTS								
Examiner Initial		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							Yes	No
		0 507 3975 A	03/26/93	JP			X	
		0 594 516 B1	05/13/98	EP				
		02-192046	07/27/90	JP				
		10-011799	01/16/98	JP			X	
		09-212915	08/15/97	JP				
		07-105575	04/21/95	JP				
	*	03286432A	12/17/91	JP				
	*	05012710	1/22/93	JP				
	*	07014221A	1/17/95	JP				
	*	07105575A	4/21/95	JP				
	*	08297858	11/12/96	JP				
	*	09007226	1/10/97	JP				
	*	08158147	1/19/98	JP				
	*	08149725	12/2/97	JP				
	*	08115029	11/28/97	JP				
	*	08050199	9/19/97	JP				
	*	08019648	8/15/97	JP				
	*	08014667	8/5/97	JP				
	*	08035523	8/5/97	JP				
	*	07139459	12/17/96	JP				
	*	07076177	10/18/96	JP				
	*	07038628	9/13/96	JP				
	*	07223758	5/17/96	JP				
	*	06253971	5/17/96	JP				
	*	06206963	3/22/96	JP				
	*	06225691	3/8/96	JP				
	*	06141602	1/12/96	JP				
	*	06143042	1/12/96	JP				
	*	06123718	12/22/95	JP				
	*	06111259	12/8/95	JP				
	*	07116045	12/8/95	JP				
	*	07036958	10/13/95	JP				
	*	06065594	10/3/95	JP				
	*	05312129	6/27/95	JP				
*	05277809	4/25/95	JP					
*	05251824	4/21/95	JP					
*	05249821	4/4/95	JP					
*	05233110	3/31/95	JP					
*	05179739	3/20/95	JP					
*	05215547	3/17/95	JP					
Examiner				Date Considered 1-13-05				
Examiner: initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number

INFORMATION DISCLOSURE CITATION				Atty. Docket No.: 7272-53		Application No.: 10/822,619		
Page 4 of 4 Pages 7272-53/312402				Applicant : Han H. Nee				
				Filing Date: April 12, 2004		Group Unit Art: 1774		
FOREIGN PATENT DOCUMENTS								
Examiner Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							Yes	No
	*	05195011	2/21/95	JP				
	*	06107566	1/6/95	JP				
	*	05115763	11/25/94	JP				
	*	05215634	9/30/94	JP				
	*	04-176039	06/23/92	JP				
	*	WO 00/21079	4/13/00	PCT				
	*	WO 97/22968	06/26/97	PCT				
	*	273193/96	10/18/96	JP				
	*	324133/92	11/13/92	JP				
	*	325406/94	05/10/93	JP				
	*	25515/99	07/03/97	JP				
	*	WO 02/2054396	07/11/02	PCT				
	*	2,401,389	07/11/02	CA				
	*	2000-402146	07/11/02	JP				
	*	2000-228032	08/15/00	JP				
	*	10-177742	06/30/98	JP				
	*	403025737	02/04/91	JP				
	*	411012734	01/19/99	JP				
	*	0 737 966 A1	10/16/96	EP				
	*	0 745 985 A2	12/04/96	EP				
	*	0 720 159 A2	07/03/96	EP				
	*	0 798 401 A2	10/01/97	EP				
	*	XP002260270	06/12/92	JP				
	*	07-006427	01/10/95	JP				
*	0 917 137 A	05/19/99	EP					
*	0 867 868 A	09/30/98	EP					

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s) publisher city and/or country where published	²
		Kirk-Othmer, Encyclopedia of Chemical Technology, 3 rd Ed., Vol. 10, pp. 247-283	
		SPIE Conference Proceeding, Vol. 2890, pp. 2-9, November 1996	
	*	Journal of the Optical Society of America, Vol. 44, No. 6, June 1954, pp. 429-438	
Examiner 		Date Considered 1-13-05	
Examiner: initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.